

**Notice of References Cited**

Application/Control No.

10/799,307

Applicant(s)/Patent Under  
Reexamination  
KIM ET AL.

Examiner

LUCY P. CHIEN

Art Unit

2871

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,015,996	03-2006	Sakamoto et al.	349/113
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

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